Search Notes

_	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/796,754	HWANG ET AL.	
	Examiner	Art Unit	
	Su C Kim	2823	

SEARCHED					
Class	Subclass	Date	Examiner		
257	E21.619	2/23/2003	SK		
257	E21.006	2/23/2003	SK		
438	300	2/23/2003	SK		
438	682	2/23/2003	SK		
438	723	2/23/2003	SK		

INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
300	2/23/2003	sĸ		
682	2/23/2003	SK		
723	2/23/2003	SK		
	300 682	Subclass Date 300 2/23/2003 682 2/23/2003		

SEARCH NOT (INCLUDING SEARCH	SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR			
East Search	2/23/2003	SK			